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(NASA-CR-192239) THE NARROW-BAND
MAXIMUM GAIN MICROWAVE AMPLIFIER.
THE NARROW-BAND LOW-NOISE MICROWAVE
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INTRODUCTION

This is the Annual Report for the NASA contract #NAG5-1049 covering the period December 1, 1990 to December 30, 1991.

This report consists of two parts:

- I. The narrow-band maximum gain microwave amplifier and
- II. The narrow-band low-noise microwave amplifier.

During this year, two graduate students worked diligently to produce some interesting results on the microwave amplifiers. In the beginning of this year, we tried to design and fabricate some solid state devices but were unable to do so because of some unforeseen circumstances.

One of the graduate students is in the process of writing her Master's thesis to be submitted sometime in the month of March, 1992. She is hard at work to get some useful experimental results.

The second graduate student, who has to complete his course work during the Spring semester of 1992, is also working for his Master's degree. Hopefully, his thesis will be ready to be submitted at the end of Summer, 1992.

One other significant outcome of this project is that a paper will be submitted for publication in January, 1992. This paper is on some interesting superconducting electronic devices. The final touches for this paper are being given at present.

I. THE NARROW-BAND MAXIMUM GAIN MICROWAVE AMPLIFIER

I. THE NARROW-BAND MAXIMUM GAIN MICROWAVE AMPLIFIER

A. GENERAL DESCRIPTION

A Narrow-band Amplifier traditionally has a bandwidth of less than 10% . The design procedures for this type of amplifier are similar to the small signal amplifier design except that the scattering, noise figure, and power-gain parameters must be measured at the center frequency of the narrow bandwidth. The maximum power gain G_{max} that can be realized for a microwave amplifier without external feedback is defined as the forward power gain when the input and output are simultaneously and conjugately matched. Conjugately matched conditions mean that the reflection coefficient Γ_s of the source is equal to the conjugate of the input reflection coefficient Γ_{in} , and the reflection coefficient Γ_L of the load is equal to the conjugate of the output reflection coefficient Γ_{out} . These are

$$\Gamma_s = \Gamma_{in}^* \quad \text{and} \quad \Gamma_L = \Gamma_{out}^*$$

The reflection coefficient of the source impedance required to conjugately match the input of the

amplifier for maximum power gain is Γ_{in} , and the reflection coefficient of the load impedance required to conjugately match the output of the amplifier is Γ_{out} . The matching networks to be designed for narrowband amplifier are shown in Figure 1.

B. DESIGN OF A NARROW-BAND AMPLIFIER FOR MAXIMUM GAIN

HFET-2201, The Hewlett - Packard device, is a gallium arsenide schottky gate field effect transistor (FET). This is designed for consistent broadband or narrow-band operation over the frequency range of 2 GHz to 18 GHz. The device's superior noise and gain performance, coupled with its wide dynamic range capability make it ideally suited for such applications as ECM, wideband surveillance, and warning systems. In addition, its characteristics lend themselves to ease of circuit design in applications such as radar and communications equipment.

The design of HFET-2201 microwave amplifier at 9 GHz center frequency consisted of two parts. First, using the s-parameters of the HFET-2201, and the

specifications that there must be a maximum gain of 14 dB at 9 GHz, a paper design was realized. This paper design was then converted into a practical design using the actual FET coupled with microstripline circuitry. The entire circuit will then be tested using the Hewlett Packard Automatic Network Analyser (ANA) 8409B.

i. THEORETICAL DESIGN

The S - parameters of the packaged HFET-2201 normalized to 50 Ω at 9 GHz (center frequency) are given by the manufacturer :

$$S_{11} = 0.84 \angle 161^\circ$$

$$S_{21} = 1.59 \angle -19^\circ$$

$$S_{12} = 0.03 \angle -30^\circ$$

$$S_{22} = 0.72 \angle -143^\circ$$

A computer program "DES2" was written and used to compute the values of the stability factor K , gain, and the impedances of the input and the output matching networks. The program listing of the "DES2" is given in Appendix A.

The stability factor K determines the stability of the system. If $K > 1$, the system is unconditionally stable. If $K < 1$, the system is potentially unstable. The stability factor calculated by using "DES2" program for this amplifier at 9 GHz is 1.27. Also, using the same program, the gain of the amplifier is calculated to be 14.1 dB. The source reflection coefficient (Γ_{in}) of $0.914 \angle -156.58^\circ$ for maximum available power gain at minimum noise figure and the load reflection coefficient (Γ_{out}) of $0.9501 \angle 152.114^\circ$ for maximum gain operation are also calculated.

a. INPUT MATCHING NETWORK DESIGN PROCEDURE

1. The input matching circuit must present the optimum source reflection coefficient ($0.914 \angle -156.58^\circ$) to the device input for high gain operation.

2. The matching network should present an equivalent source impedance Z_{sin} .

$$Z_{sin} = Z_o (1 + \Gamma_{in}) / (1 - \Gamma_{in}). \quad \text{-----}>(1)$$

Where Z_{sin} = Source input impedance.

Z_o = Characteristic impedance (50 Ω).

$$\Gamma_{in} = |\Gamma_{in}| \cos \angle \Gamma_{in} + j |\Gamma_{in}| \sin \angle \Gamma_{in}. \quad \text{---> (2)}$$

Substituting equation(2) in equation(1) and then multiplying the numerator and denominator of the resultant by the conjugate of the denominator results in the source equivalent impedance for maximum power gain :

$$\begin{aligned} Z_{sin} &= Z_o (1 - |\Gamma_{in}| + j 2 |\Gamma_{in}| \sin \angle \Gamma_{in}) \\ &\quad (1 + |\Gamma_{in}| - 2 |\Gamma_{in}| \cos \angle \Gamma_{in}). \\ &= 10.636 \angle -77.36^\circ. \end{aligned}$$

$$\begin{aligned} Y_{sin} &= 1/Z_{sin} \\ &= 0.094 \angle 77.36^\circ. \end{aligned}$$

3. An open stub of length $3\lambda/8$ works like a shunt inductor with a characteristic impedance of

$$\begin{aligned} Z_{o1} &= 1/\text{Im}[Y_{sin}] \\ &= 10.9 \Omega. \end{aligned}$$

4. A transmission line with $\lambda/4$ in length will match the 50Ω source resistance with the real part of Y_{sin} . Its characteristic impedance is

$$\begin{aligned} Z_{o2} &= \sqrt{50/\text{Re}[Y_{sin}]} \\ &= 49.22 \Omega. \end{aligned}$$

b. OUTPUT MATCHING NETWORK DESIGN PROCEDURE

1. The output matching circuit must present the optimum load reflection coefficient ($0.8501 \angle 152.114^\circ$) to the device output for high gain operation.

2. The load equivalent impedance for maximum power gain is

$$\begin{aligned} Z_{l0} &= 13.088 \angle 70.86^\circ. \\ Y_{l0} &= 1/Z_{l0} \\ &= 0.0764 \angle -70.86^\circ. \end{aligned}$$

3. An open stub of length $3\lambda/8$ works like a shunt inductor with a characteristic impedance of

$$Z_{o3} = 13.857 \Omega.$$

4. A quarter-wave transformer is needed to transform the load equivalent impedance to the load resistance of 50 Ω . Its characteristic impedance is

$$\begin{aligned} Z_{o4} &= \sqrt{Z_o / \text{Im}[Y_{lo}]} \\ &= 44.64 \Omega. \end{aligned}$$

The designed matching networks for the HFET-2201 amplifier are shown in Fig.2.

Figure 2 can be modified as shown in Fig. 3 for symmetry and balance in microstrip lines. The open stub Z_{O1} of impedance 10.9 Ω in Figure 2 is converted into two parallel open stubs Z_1 , Z_2 of equal impedance as shown in Fig. 3. Similarly, Z_{O3} is also converted into two parallel open stubs Z_4 and Z_5 .

c. MICROSTRIP DESIGN

Using Duriod as the microstrip substrate with relative dielectric constant ϵ_r of 10.2 and thickness of 25 mils, the effective dielectric constant ϵ_{eff} and the width of the microstripline for various impedances are found by using the computer program "IMPDE7".

The listing of this program is given in Appendix A. ϵ_{eff} , width and lengths of the microstrip for the original and modified matching network elements are given in Tables 1 and 2 respectively. The modified matching network elements Z_1 , Z_2 , Z_3 , Z_4 , Z_5 and Z_6 with their lengths and widths are shown in Figure 4. The wavelength (λ) was found by using the expression

$$\lambda = c/f \sqrt{\epsilon_{\text{eff}}} .$$

Where c is the velocity of light (3×10^{10} cm/Sec).

f is the frequency of operation (9 GHz) of the HFET-2201.

ii. PRACTICAL DESIGN

In the paper design, the lengths and configurations of the microstriplines were determined. These lengths and configurations were then realized by fabricating the microstrip circuitry in the solid state laboratory. The FET was then carefully mounted on to the circuitry to obtain the amplifier circuit. The circuit realization pattern on duroid substrate is

shown in Figure 4A. The input circuit occupies an area of 343.18 mil by 375.74 mil, while the output circuit takes 315.02 mil by 387.54 mil area.

STEP 1. Using the configuration of the circuit in Figure 4A the transmission lines were first drawn to an expanded scale of 1" to 10". A pattern of this configuration was then cut out on a sheet of Rubylith. Once the pattern was satisfactory, it was then attached to a light-box and a photograph of this configuration was taken. The photograph was taken such that the image was reduced to the actual size of the circuit which was calculated in the paper design.

STEP 2. The film was then taken to the dark-room where the negatives were developed. Two exposures were taken to ensure that a good result would be obtained. Then the exposures were placed in a developing solution until the film was developed satisfactorily. After a satisfactory picture was obtained, the film was washed and placed in a fixing solution which stopped further developing and gave the fixed picture. This slide was then used as a mask for the remainder of the experiment.

STEP 3. The mask was then used to obtain the actual circuit which consisted of copper on a substrate of duroid. A piece of duroid was cut from a sheet to about the size of the mask, and then taken to the Solid State Laboratory for processing. The duroid was first cleaned using acetone followed by methanol, and then washed with deionized water. The duroid was then blow-dried using an air gun. Microposit photoresist was then smeared over the entire surface of the duroid and it was then spun for 20 seconds at 4,000 r.p.m. in the spinner. This procedure allowed a thin film of photoresist of 1.2 microns to be evenly distributed over the surface of the duroid. The duroid was then pre-baked at 96 degrees celsius for 20 minutes. At this time the duroid was ready to be mask-aligned. In this process, the mask was placed over the duroid and exposed to ultraviolet light for 15 seconds, using the mask-aligner. The Duroid was then placed into a Microposit 351 Developing solution where an image of the mask was realized. The duroid was then placed in a solution of Toluene where the image was fixed and hardened. At this time, the duroid was washed with de-ionized water and then blow-dried. It was then post-baked at 120 degrees celsius for half an hour.

STEP 4. Since the back portion of the Duroid had to remain copper coated, it was smeared with photoresist and then baked for half an hour. This procedure ensured that the back of the duroid would not be attacked during the etching procedure.

STEP 5. The duroid was then placed in an etching solution which consisted of a mixture of iron chloride and water. This etchant removed all of the copper from around the image of the copper stripline and did not attack the copper at the back of the duroid. In the end, all that was left was the copper stripline pattern in the front portion, and a copper coated back portion. This back portion acted as a ground plane.

STEP 6. The FET was then mounted on the duroid with the gate and the drain terminals fixed to the ends of the microstrip lines and the source was attached to the back of the duroid. The terminals were fixed to the duroid using conducting epoxy.

STEP 7. The circuit will then be tested on the Hewlett Packard Automatic Network Analyzer (ANA) 8409B.

Table 1.

ELEMENT	VALUE	WIDTH	E _{eff}	g	LENGTH
	(Ω)	(mil)		(mil)	(mil)
Z01	10.9	224.0	8.595	447.59	(3/8) g = 187.85
Z02	49.22	24.0	6.85	501.42	(1/4) g = 125.35
Z03	13.858	165.7	8.34	454.32	(3/8) g = 170.37
Z04	44.64	29.1	6.97	497.16	(1/4) g = 124.29

Table 2.

ELEMENT	VALUE	WIDTH	E _{eff}	g	LENGTH
	(Ω)	(mil)		(mil)	(mil)
Z1=2*Z01	21.8	92.3	7.83	468.99	175.87
Z2=2*Z01	21.8	92.3	7.83	468.99	175.87
Z3=Z02	49.22	24.0	6.85	501.42	125.35
Z4=2*Z03	27.806	65.2	7.54	477.92	179.22
Z5=2*Z03	27.806	65.2	7.54	477.92	179.22
Z6=Z04	44.64	29.1	6.97	497.16	124.29

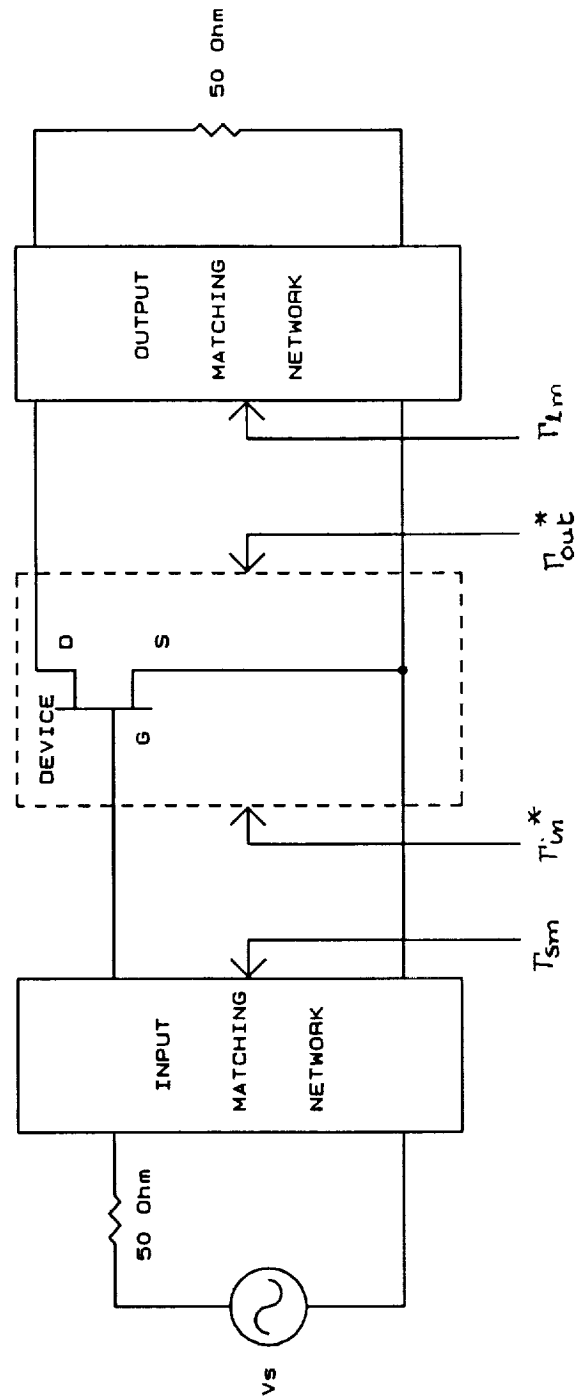


Fig. 1

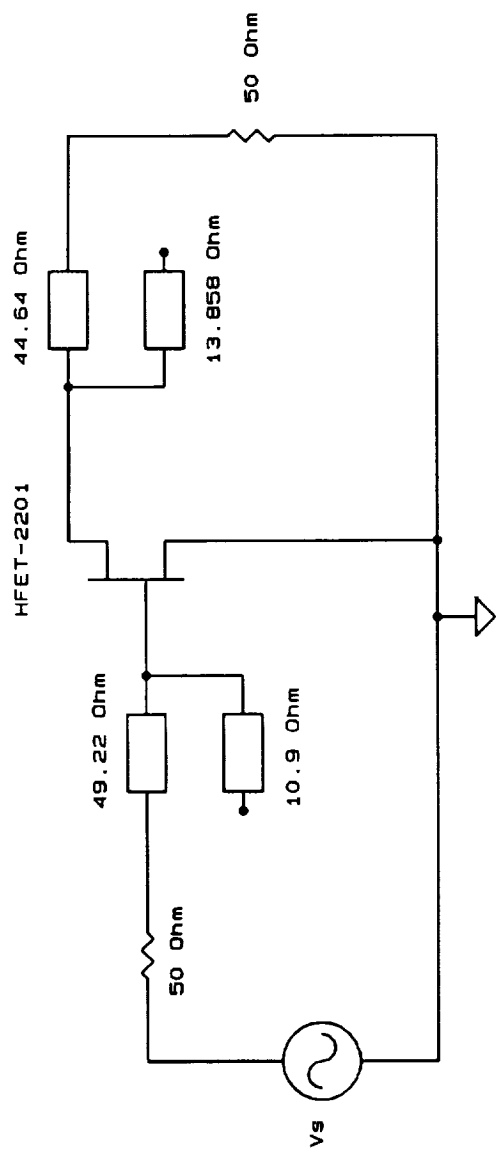


Fig. 2

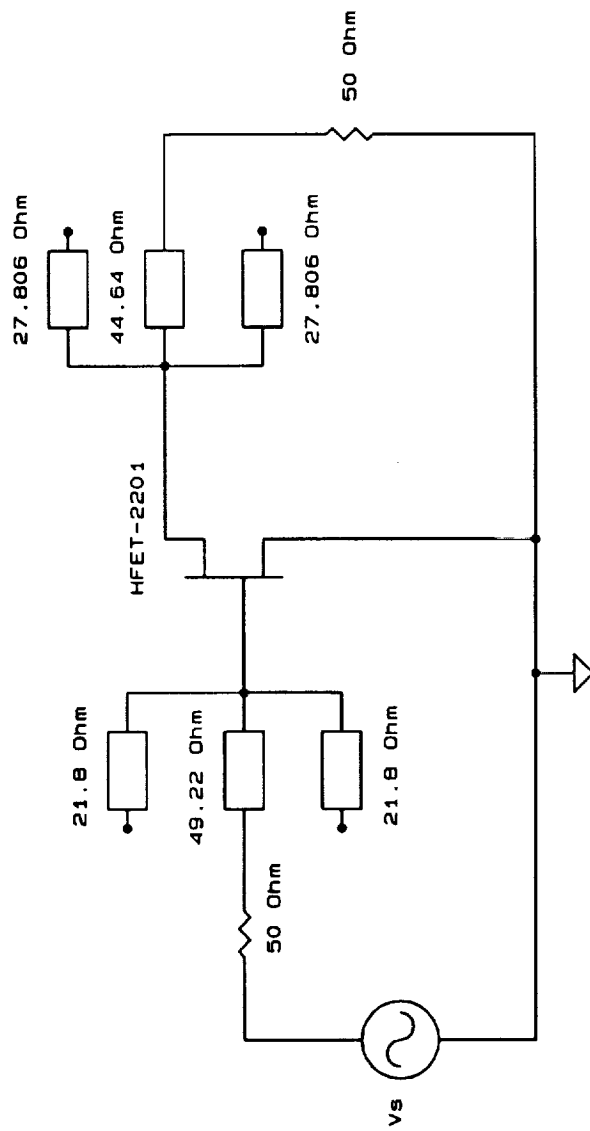


Fig. 3

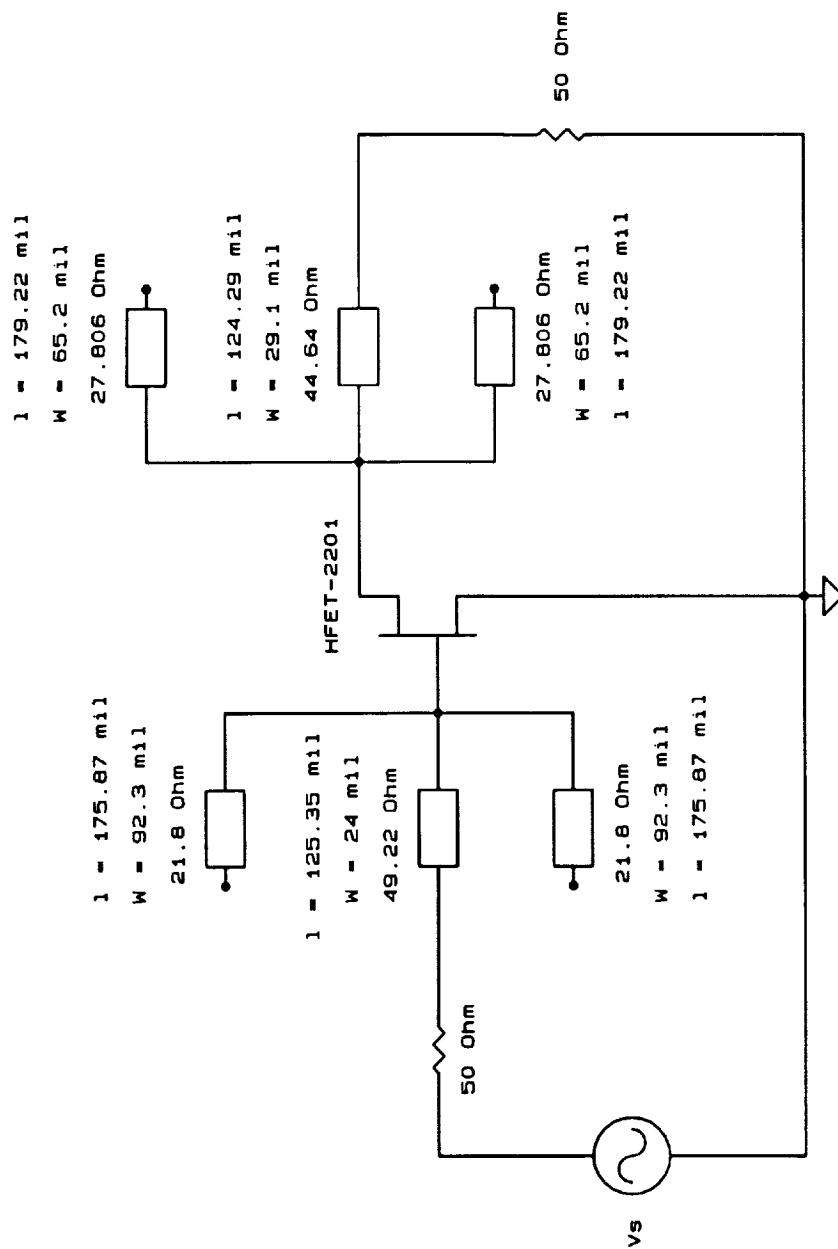


Fig.4

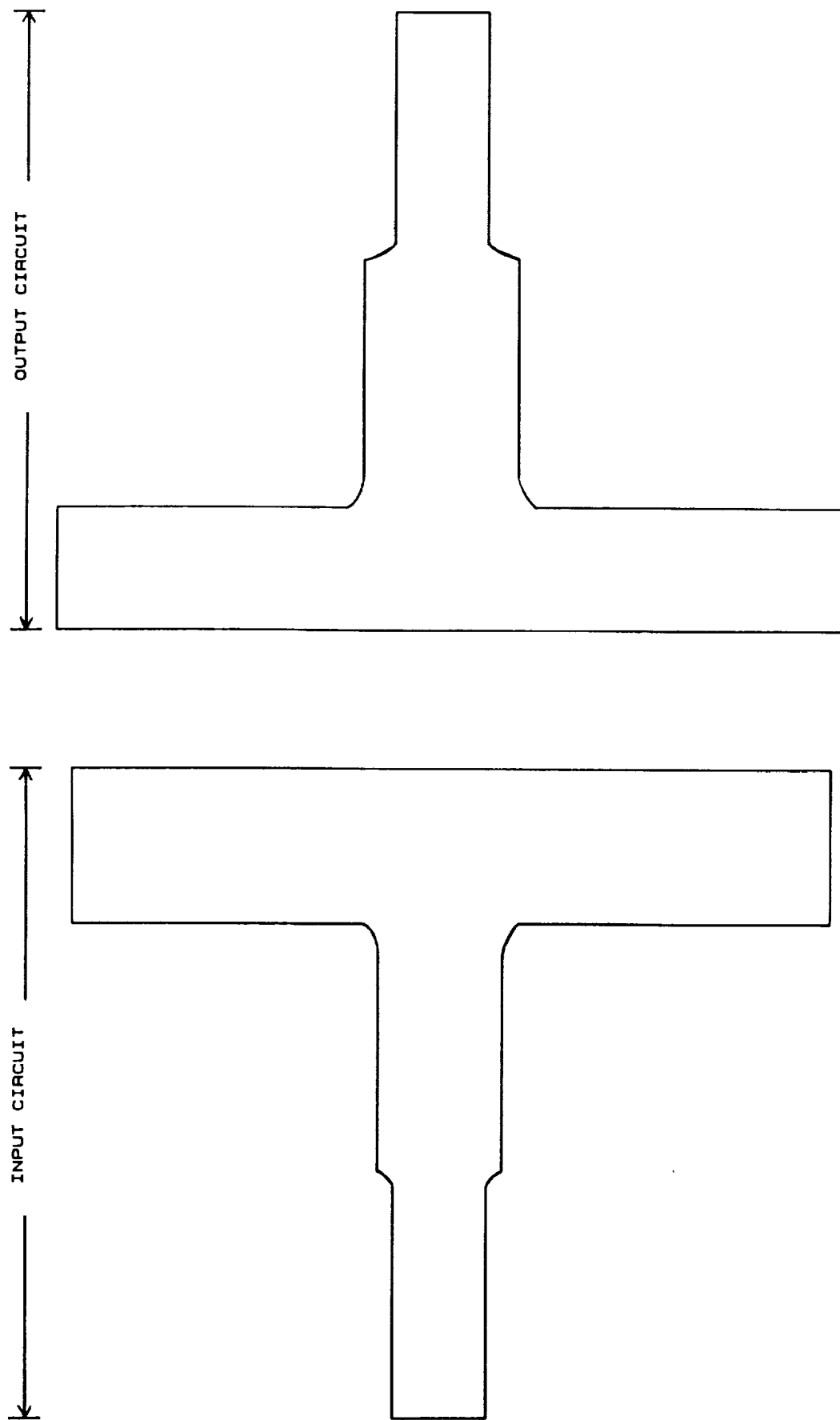


FIG. 4A. MICROSTRIP DESIGN

II. THE NARROWBAND LOW-NOISE MICROWAVE AMPLIFIER

II THE NARROWBAND LOW-NOISE MICROWAVE AMPLIFIER

Because of the increasing need for Microwave amplifiers in rapidly developing areas such as remote sensing, spaceborne and terrestrial communication systems, airborne and land based radar systems, microwave amplifier design is increasingly becoming a very important part of electrical engineering.

Several Distinct microwave amplifier design procedures exist based on the anticipated use and application environment of the amplifier. Table 3 shows some of the more commonly used microwave amplifiers tabulated according to their design procedure.

This section of the report is based on the design of a low-noise microwave amplifier using the HP HXTR-6104 low-noise transistor.

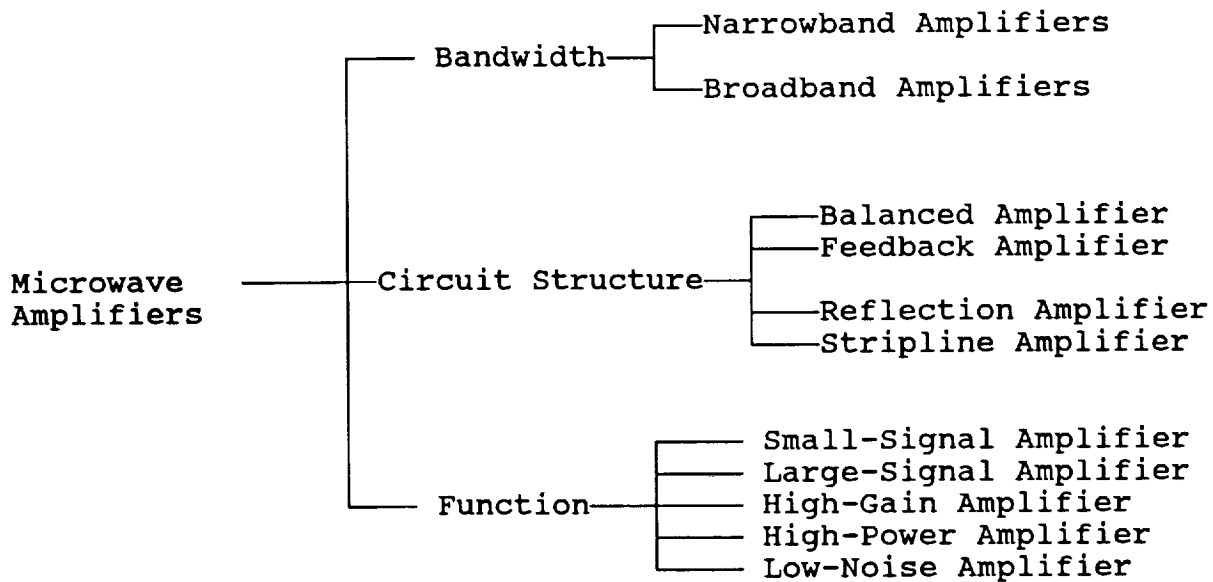


Table 3. Microwave amplifiers tabulated according to design procedure.

Amplifier Stability:

One of the basic and most critical factors in the design consideration of any microwave amplifier is the amplifier stability. The stability of an amplifier is its resistance to oscillation, and can be determined by the accurate measurement of its (scattering) S-parameters and the impedance of its simulated source and loads. an amplifier will become unstable if either its source or load has a negative resistance, or when either of the scattering parameters S_{11} and/or S_{22} is greater than unity.

These areas of operation of an amplifier should usually be avoided, although it can be shown that even with negative resistances, the amplifier can still be operated in a very small stable region if other design factors are taken into consideration. The stability of a microwave amplifier can be subdivided into two types.

1. Unconditional Stability:

The amplifier is unconditionally stable if the real parts of the impedances at both its input and output ports are greater than zero for ALL positive real source and load impedances at a specific frequency.

2. Conditional Stability:

The amplifier is conditionally stable if the real part of the impedances at both its input and output ports are greater than zero for SOME positive real source and load impedances at a particular frequency.

Positive real source and load impedances mean that :

$$\Gamma_s \quad \text{and} \quad \Gamma_L \quad \leq \quad 1$$

For unconditional stability, the magnitudes of S_{11} , S_{22} , Γ_{ϵ} , and Γ_{out} must all be smaller than 1, and at the same time, the device's stability factor K must be greater than unity.

$$K = \frac{1 + |\Delta|^2 - |S_{11}|^2 - |S_{22}|^2}{2 |S_{11} S_{21}|} > 1$$

$$\text{Where } |\Delta| = |S_{11} S_{22} - S_{12} S_{21}| < 1$$

The input reflection coefficient:

$$\Gamma_{\epsilon} = S_{11} + \frac{S_{12}S_{21}\Gamma_L}{1 - S_{22}\Gamma_L}$$

The output reflection coefficient:

$$\Gamma_{out} = S_{22} + \frac{S_{12}S_{21}\Gamma_s}{1 - S_{11}\Gamma_s}$$

Stability circles which separate the input or output planes into stable and potentially unstable regions can be drawn on a Smith chart or calculated. A stability circle drawn on the output plane shows all loads that will cause oscillation by providing negative real input impedance, while the stability circle drawn on the input plane shows all loads that cause oscillation by supplying negative real output impedance. The regions of instability occur within the circles.

The boundary conditions for stability are:

$$|\Gamma_{\epsilon}| = \left| S_{11} + \frac{S_{12}S_{21}\Gamma_L}{1 - S_{22}\Gamma_L} \right| \leq 1$$

and

$$|\Gamma_{out}| = \left| S_{22} + \frac{S_{12}S_{21}\Gamma_s}{1 - S_{11}\Gamma_s} \right| \leq 1$$

The radius of the Γ_s circle =

$$r_s = \frac{S_{11}S_{21}}{||S_{11}|^2 - |\Delta|^2|}$$

The center of the Γ_s circle =

$$C_s = \frac{C_s^*}{|S_{11}|^2 - |\Delta|^2}$$

The radius of the Γ_L circle =

$$r_L = \frac{|S_{12}S_{21}|}{||S_{22}|^2 - |\Delta|^2|}$$

The center of the Γ_L circle =

$$C_L = \frac{C_L^*}{|S_{22}|^2 - |\Delta|^2}$$

where

$$\Delta = S_{11}S_{22} - S_{12}S_{21}$$

$$C_s = S_{11} - \Delta S_{22}^*$$

$$C_L = S_{22} - \Delta S_{11}^*$$

Finally, The stability Criteria are as follows:

a: Unconditional stability

$$K > 1 \quad \text{and} \quad |\Delta| < 1$$

$$||C_s| - r_s| > 1 \quad \text{for} \quad |S_{22}| < 1$$

$$||C_L| - r_L| > 1 \quad \text{for} \quad |S_{11}| < 1$$

b: Conditional stability

$$K > 1 \quad \text{and} \quad |\Delta| < 1$$

$$||C_s| - r_s| < 1 \quad \text{for} \quad |S_{22}| < 1$$

$$||C_L| - r_L| < 1 \quad \text{for} \quad |S_{11}| < 1$$

c: Potential instability

$$K > 1 \quad \text{and} \quad |\Delta| < 1$$

or

$$K < 1 \quad \text{and} \quad |\Delta| < 1$$

The stability conditions can be shown Graphically on a Smith chart. To achieve unconditional stability, all passive source and load impedances must produce stability circles which are completely outside the Smith chart as shown in figure 5. A potentially unstable situation arises when the stability circle overlaps the Smith chart as shown in figure 6.

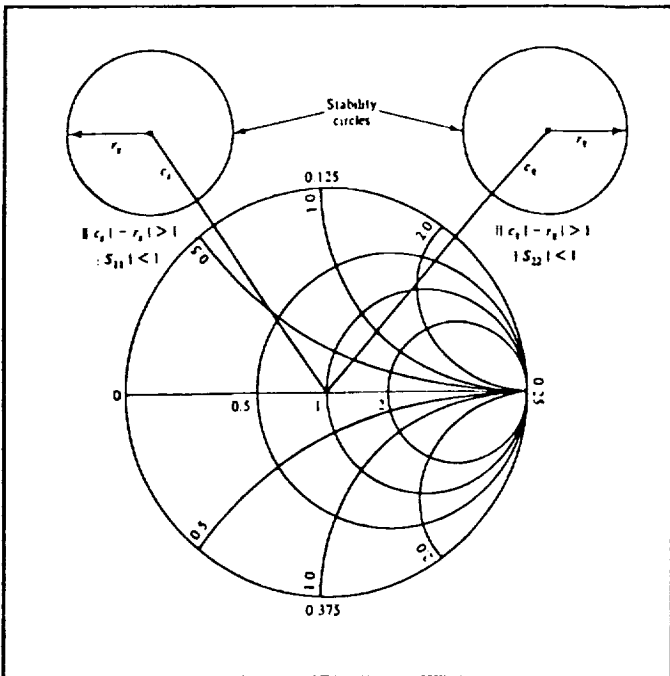


Figure 5. Locations of Unconditional stability circles on the Smith chart.

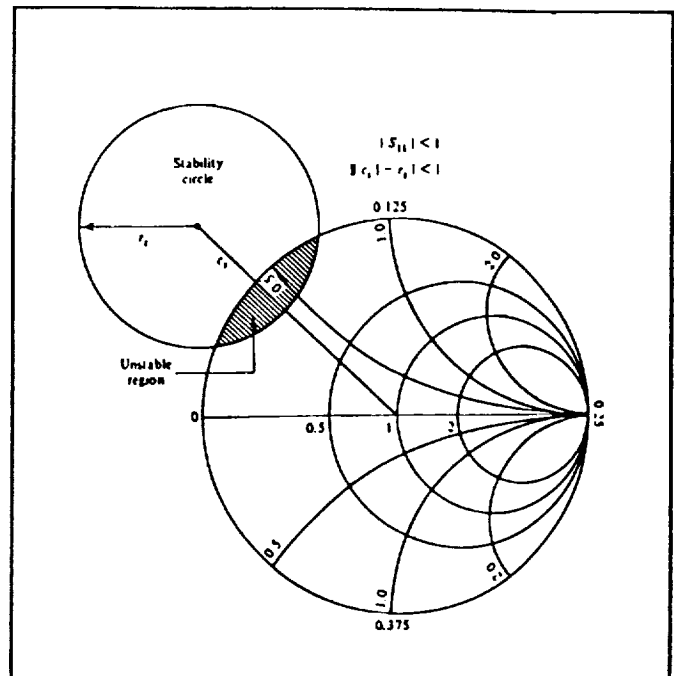


Figure 6. Location of Conditional stability circle on the Smith chart.

In the general design procedure for microwave, the maximum gain and the minimum noise-figure are equally important, but because of conflicting design constraints, the maximum gain and minimum noise-figure cannot be achieved simultaneously. Therefore, a trade-off is usually made between high-gain and low-noise, often sacrificing one for the other. In some amplifier stages such as the Pre-amplifier, the minimum noise-figure will be given more design consideration than the power-gain. The basic goal of the low-noise design procedure is to design input and output matching networks, which will allow the device to be operated at its minimum noise-figure. The design parameters and final configuration of the low-noise amplifier matching networks are as shown in figure 7.

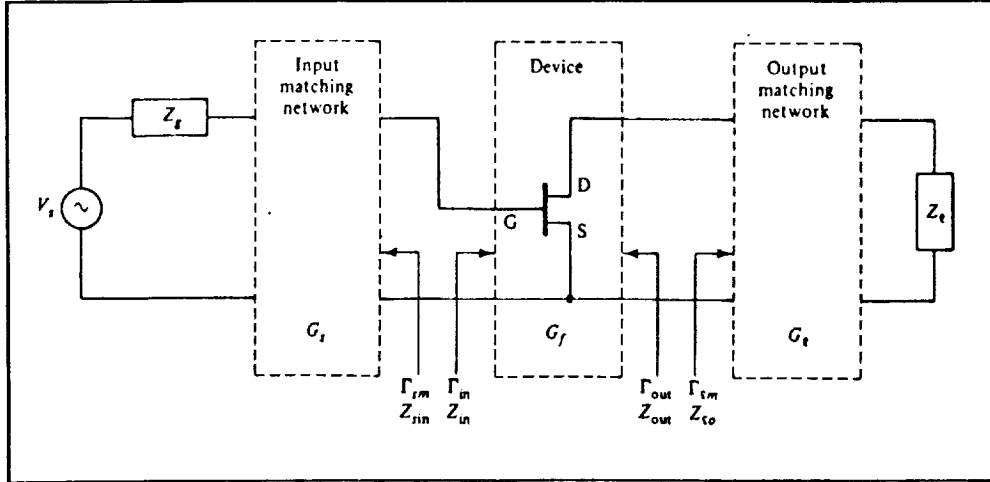


Figure 7. The design parameters for the matching networks of the low-noise amplifier

For minimum noise-figure, the source equivalent impedance is given as follows:

$$Z_{sn} = \frac{Z_o (1 - |\Gamma_o|^2) + j2Z_o \sin(\angle \Gamma_o)}{1 + |\Gamma_o|^2 - 2|\Gamma_o| \cos(\angle \Gamma_o)}$$

where Γ_o is the optimum source reflection coefficient for minimum noise-figure (usually supplied by the manufacturer of the device).

The load equivalent impedance for minimum noise-figure is given as follows:

$$Z_{Ln} = \frac{Z_o (1 - |\Gamma_L|^2) + j2Z_o \sin(\angle \Gamma_L)}{1 + |\Gamma_L|^2 - 2|\Gamma_L| \cos(\angle \Gamma_L)}$$

where Γ_L is the optimum load reflection coefficient for minimum noise-figure F_{min} .

Using the design equations supplied, the design steps and results for designing a Narrowband amplifier for minimum noise-figure using the HP HXTR-6104 are presented. The design procedure is subdivided into two parts.

Part a: The design of the input matching network.

Part b: The design of the output matching network.

A: The design of the input matching network.

Step 1. Determine the source equivalent impedance for minimum noise-figure.

$$Z_{sn} = \frac{Z_o(1 - |\Gamma_o|^2) + j2Z_o \sin(\angle \Gamma_o)}{1 + |\Gamma_o|^2 - 2|\Gamma_o| \cos(\angle \Gamma_o)}$$

$$Z_{sn} = \frac{50(1 - |0.323|^2) + j100 \sin(94)}{1 + |0.323|^2 - 2(0.323) \cos(94)} = \frac{109.348 \angle 65.82^\circ}{1.149}$$

$$Z_{sn} = 38.97 + j86.78 \Omega$$

Step 2. Convert Z_{sn} to Y_{sn}

$$Y_{sn} = \frac{1}{Z_{sn}} = \frac{1}{38.97 + j86.79} = 0.0043 - j0.0096 \text{ S}$$

Step 3. Use a three-eighths wavelength open-circuited stub which provides a shunt inductance of $-jY_o$.

$$Z_{o1} = \frac{1}{Y_o} = \frac{1}{0.0096} = 104.28 \Omega$$

Step 4. Use a quarter -wavelength transformer to transform the load resistance to the load equivalent conductance.

$$Z_{o2} = \sqrt{\frac{Z_o}{Y_o}} = \sqrt{\frac{50}{0.0043}} = 107.83 \Omega$$

where Z_o is the characteristic Impedance.

B: The design of the output matching network.

Step 1. Determine the load equivalent impedance for the minimum noise-figure.

$$Z_{Ln} = \frac{Z_o (1 - |\Gamma_L|^2) + j2Z_o \sin(\angle \Gamma_L)}{1 + |\Gamma_L|^2 - 2|\Gamma_L| \cos(\angle \Gamma_L)}$$

$$= \frac{50(1 - |0.6871|^2) + j100 \sin(46.21)}{1 + |0.6871|^2 - |0.6871| \cos(46.21)}$$

$$= 50.636 + j138.52 \Omega$$

Step 2. Convert Z_{Ln} to Y_{Ln}

$$Y_{Ln} = \frac{1}{Z_{Ln}}$$

$$= \frac{1}{50.636 + j138.52} = 0.0023 - j0.0064 \text{ S}$$

Step 3. Use a three-eighths wavelength open-circuited stub which provides a shunt inductance of $-jY_o$.

$$Z_{o1} = \frac{1}{Y_o} = \frac{1}{0.0064} = 157.02 \Omega$$

Step 4. Use a quarter-wavelength transformer to match the load equivalent impedance to the load resistance.

$$Z_{o2} = \sqrt{\frac{Z_o}{Y_o}} = \sqrt{\frac{50}{0.0023}} = 146.55 \Omega$$

The final matching network is shown in figure 8.

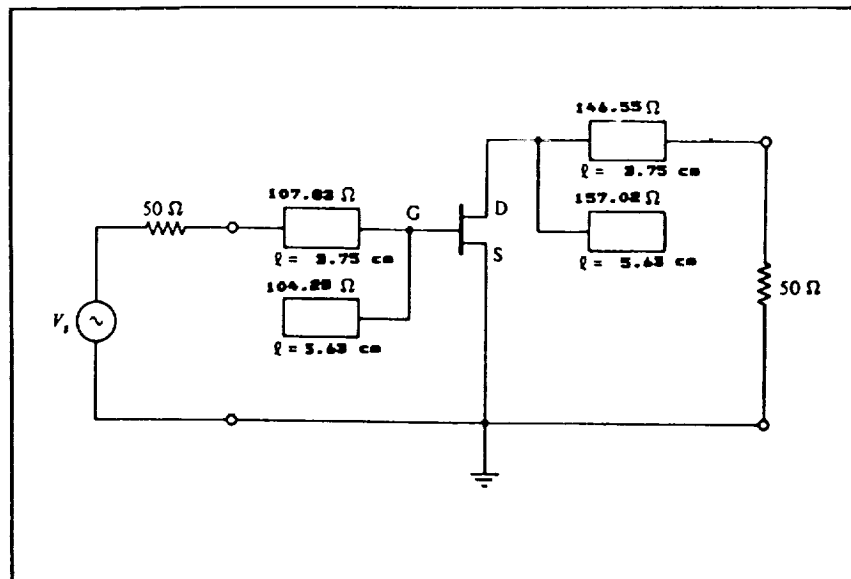


Figure 8. The designed matching networks of the low-noise amplifier

Appendix B is a listing of a pascal program written on the HP-3000 computer to calculate all of the design parameters that are needed to design a low-noise amplifier using the Scattering parameters of the active device. This program can also be used to design an amplifier using the maximum gain procedure.

APPENDIX A


```

EM Program: Design of a GaAs FET Amplifier for Maximum Gain
RINT "Enter the Device name" : PRINT
INPUT DEVICE
RINT "Enter S-parameters"
INPUT S11M,S11A,S21M,S21A,S12M,S12A,S22M,S22A
PRINT "Enter Frequency (GHz)"
INPUT FREQUENCY
A=S11M*S22M
A1=S11A+S22A
B=A1*3.14/180
C=A*COS(B) : D=A*SIN(B)
E=S21M*S12M
F1=S21A+S12A : F= F1*3.14/180
G=E*COS(F) : H=E*SIN(F)
DELT1=C-G
DELT2=D-H
DELTM=SQR(DELT1^2+DELT2^2)
DELTA=(ATN(DELT2/DELT1))*180/3.14
IF DELT1<0 AND DELT2<0 THEN DELTA=DELTA-180
IF DELT1<0 AND DELT2>0 THEN DELTA=DELTA+180
K=(1+DELTM^2-S11M^2-S22M^2)/(2*S12M*S21M)
IF K<1 THEN 1350
GAIN=10*LOG(S21M/S12M)*(K-SQR(K^2-1))
PRINT DELTM,DELTA,K
B1=1+S11M^2-S22M^2-DELTM^2
B2=1+S22M^2-S11M^2-DELTM^2
S22A1=-S22A : M=DELTM*S22M : N=DELTA+S22A1 : O=N*3.14/180
P=M*COS(O) : Q=M*SIN(O) : R=S11M*COS(S11A*3.14/180)
S=S11M*SIN(S11A*3.14/180)
REC1=R-P : IMC1=S-Q
C1M=SQR((R-P)^2+(S-Q)^2) : C1A=(ATN((S-Q)/(R-P)))*180/3.14
IF REC1<0 AND IMC1<0 THEN C1A=C1A-180
IF REC1<0 AND IMC1>0 THEN C1A=C1A+180
T=DELTM*S11M : U=DELTA-S11A : V=U*3.14/180 : W=T*COS(V) : X=T*SIN(V)
Y=S22M*COS(S22A*3.14/180) : Z=S22M*SIN(S22A*3.14/180)
REC2=Y-W : IMC2=Z-X
C2M=SQR((W-Y)^2+(X-Z)^2) : C2A=(ATN((X-Z)/(W-Y)))*180/3.14
IF REC2<0 AND IMC2<0 THEN C2A=C2A-180
IF REC2<0 AND IMC2>0 THEN C2A=C2A+180
COEFF=(B1^2-4*C1M^2)
IF COEFF<0 THEN 340
FACTOR=SQR(COEFF)
IF B1>0 THEN 300
RADICALM=B1+FACTOR
GOTO 310
RADICALM=B1-FACTOR
MULTM=RADICALM*C1M
MULTA=-C1A
GOTO 430
FACTOR=SQR(-COEFF)
RADICALM=SQR(B1^2+FACTOR^2)
IF B1>0 THEN 390

```

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RADICALA=(ATN(FACTOR/B1))*180/3.14
IF B1<0 AND FACTOR<0 THEN RADICALA=RADICALA-180
IF B1<0 AND FACTOR>0 THEN RADICALA=RADICALA+180
GOTO 410
RADICALA=(ATN(-FACTOR/B1))*180/3.14
GOTO 372
MULTM=RADICALM*C1M
MULTA=RADICALA-C1A
TSMM=MULTM/(2*C1M^2)
TSMA=MULTA
ZO=50
IMZSIN=(2*TSMM*SIN(TSMA*3.14/180))*ZO/((1+TSMM^2-2*TSMM*COS(TSMA*3.14/180)))
REZSIN=(ZO*(1-TSMM^2))/((1+TSMM^2-2*TSMM*COS(TSMA*3.14/180)))
ZSINM=SQR(IMZSIN^2+REZSIN^2)
ZSINA=(ATN(IMZSIN/REZSIN))*180/3.14
IF REZSIN<0 AND IMZSIN<0 THEN ZSINA=ZSINA-180
IF REZSIN<0 AND IMZSIN>0 THEN ZSINA=ZSINA+180
YSINM=1/ZSINM
YSINA=-ZSINA
REYSIN=YSINM*COS(YSINA*3.14/180)
IMYSIN=YSINM*SIN(YSINA*3.14/180)
ZO1=1/ABS(IMYSIN)
IMPE=ZO/ABS(REYSIN)
ZO2=IMPE^.5
OPCOEFF=(B2^2-4*C2M^2)
IF OPCOEFF<0 THEN 770
OPFACTOR=SQR(OPCOEFF)
IF B2>0 THEN 730
OPRADICALM=B2+OPFACTOR
GOTO 740
OPRADICALM=B2-OPFACTOR
OPMULTM=OPRADICALM*C2M
OPMULTA=-C2A
GOTO 850
OPFACTOR=SQR(-OPCOEFF)
OPRADICALM=SQR(B2^2+OPFACTOR^2)
IF B2>0 THEN 820
OPRADICALA=(ATN(OPFACTOR/B2))*180/3.14
IF B2<0 AND OPFACTOR<0 THEN OPRADICALA=OPRADICALA-180
IF B2<0 AND OPFACTOR>0 THEN OPRADICALA=OPRADICALA+180
GOTO 830
OPRADICALA=(ATN(-OPFACTOR/B2))*180/3.14
GOTO 802
OPMULTM=OPRADICALM*C2M
OPMULTA=OPRADICALA-C2A
TLMM=OPMULTM/(2*C2M^2)
TLMA=OPMULTA
IMZLO=(2*TLMM*ZO*SIN(TLMA*3.14/180))/((1+TLMM^2-2*TLMM*COS(TLMA*3.14/180)))
) REZLO=ZO*(1-TLMM^2)/((1+TLMM^2-2*TLMM*COS(TLMA*3.14/180)))
) ZLOM=SQR(IMZLO^2+REZLO^2)
) ZLOA=(ATN(IMZLO/REZLO))*180/3.14
) IF REZLO<0 AND IMZLO<0 THEN ZLOA=ZLOA-180
) IF REZLO<0 AND IMZLO>0 THEN ZLOA=ZLOA+180
) YLOM=1/ZLOM
) YLOA=-ZLOA
) REYLO=YLOM*COS(YLOA*3.14/180)
) IMYLO=YLOM*SIN(YLOA*3.14/180)
) MZ1=1/ABS(IMYLO)
) OUTZ=ZO/ABS(REYLO)
) MZ2=SQR(OUTZ)

```

```

1 LPRINT "***** RESULTS *****"
5 LPRINT TAB(10); "Device is HFET - "; TAB(31); DEVICE
0 LPRINT "Given s-parameters are:"
5 LPRINT
0 LPRINT TAB(5); "s11m"; TAB(20); "s11a"; TAB(35); "s21m"; TAB(50); "s21a"
3 LPRINT
5 LPRINT TAB(5); S11M; TAB(20); S11A; TAB(35); S21M; TAB(50); S21A : LPRINT
6 LPRINT TAB(5); "s12m"; TAB(20); "s12a"; TAB(35); "s22m"; TAB(50); "s22a" : LPRINT
3 LPRINT TAB(5); S12M; TAB(20); S12A; TAB(35); S22M; TAB(50); S22A : LPRINT
9 LPRINT
0 LPRINT TAB(7); "k"; TAB(20); "gain"; TAB(35); "frequency" : LPRINT
2 LPRINT TAB(7); K; TAB(20); GAIN; TAB(35); FREQUENCY : LPRINT
5 LPRINT
0 LPRINT TAB(5); "magnitude of delta"; TAB(30); "angle of delta" : LPRINT
5 LPRINT TAB(10); DELTM; TAB(35); DELTA : LPRINT
6 LPRINT
0 LPRINT TAB(5); "B1"; TAB(20); "B2" : LPRINT
2 LPRINT TAB(5); B1; TAB(20); B2 : LPRINT : LPRINT
0 LPRINT TAB(5); "magnitude of C1"; TAB(25); "angle of C1"; TAB(45); "magnitude of
"; TAB(65); "angle of C2"
1 LPRINT
5 LPRINT TAB(10); C1M; TAB(30); C1A; TAB(50); C2M; TAB(70); C2A : LPRINT
0 LPRINT
0 LPRINT "***** input matching network design *****": LPRINT
5 LPRINT
0 LPRINT " source reflection coefficient ": LPRINT
2 LPRINT TAB(5); "magnitude of Tsm"; TAB(35); "angle of Tsm" : LPRINT
3 LPRINT TAB(10); TSMM; TAB(40); TSMA : LPRINT : LPRINT
0 LPRINT "determination of source equivalent impedance"
5 LPRINT
0 LPRINT TAB(5); "magnitude of Zsin"; TAB(35); "angle of Zsin" : LPRINT
2 LPRINT TAB(10); ZSINM; TAB(40); ZSINA : LPRINT : LPRINT
5 LPRINT "impedances of the input matching network:" : LPRINT
7 LPRINT TAB(5); "Impedance associated with 3/8 is Zo1"; TAB(45); "Impedance
associated with 1/4 is Zo2" : LPRINT
9 LPRINT TAB(15); ZO1; TAB(55); ZO2 : LPRINT
0 LPRINT
0 LPRINT
0 LPRINT "***** output matching network design *****": LPRINT
5 LPRINT
0 LPRINT " load reflection coefficient ": LPRINT : LPRINT
2 LPRINT TAB(5); "magnitude of Tlm"; TAB(35); "angle of Tlm" : LPRINT
4 LPRINT TAB(10); TLMM; TAB(40); TLMA : LPRINT : LPRINT
0 LPRINT "determination of load equivalent impedance"
5 LPRINT
0 LPRINT TAB(5); "magnitude of Zlo"; TAB(35); "angle of Zlo" : LPRINT
2 LPRINT TAB(10); ZLOM; TAB(40); ZLOA : LPRINT : LPRINT
0 LPRINT "impedances of the output matching network:" : LPRINT
2 LPRINT TAB(5); "Impedance associated with 3/8 is Z1"; TAB(45); "Impedance as
iated with 1/4 is Z2" : LPRINT
4 LPRINT TAB(15); MZ1; TAB(55); MZ2
5 END
6 LPRINT "***** RESULTS *****"
0 LPRINT TAB(10); "Device is HFET - "; TAB(31); DEVICE
0 LPRINT "Given S-parameters are:"
5 LPRINT
0 LPRINT TAB(5); "s11m"; TAB(20); "s11a"; TAB(35); "s21m"; TAB(50); "s21a"
5 LPRINT
0 LPRINT TAB(5); S11M; TAB(20); S11A; TAB(35); S21M; TAB(50); S21A
0 LPRINT
0 LPRINT TAB(5); "s12m"; TAB(20); "s12a"; TAB(35); "s22m"; TAB(50); "s22a"

```

```

LPRINT
LPRINT TAB(5);S12M;TAB(20);S12A;TAB(35);S22M;TAB(50);S22A
LPRINT : LPRINT : LPRINT
LPRINT TAB(7);"k";TAB(20);"magnitude of delta";TAB(45);"angle of delta" : L
T
LPRINT TAB(5);K;TAB(25);DELTM;TAB(50);DELTA
LPRINT "Frequency" : LPRINT
LPRINT FREQUENCY : LPRINT
LPRINT
LPRINT TAB(5);"since  $k < 1$ , the system is potentially unstable"
END

```

IMPDE7

```

REM PROGRAM TO CALCULATE Zo AND
Ef.
I=25
E=10.2
LPRINT TAB(5); "W"; TAB(30); "Ereff"; TAB(50); "Zo"
FOR W=1 TO 100 STEP 1
  E=W/H
  A=(E+1)/2
  B=(E-1)/2
  C=(1+12/X)^(-.5)
  IF X<1 THEN 180
  E1=A+B*C
  REM Ereff=((Er+1)/2)+((Er-1)/2)*(1+12/X)**(-.5)
  G=(120*3.14)/(E1^.5)
  I=X+1.393+.667*LOG(X+1.444)
  Z=G/I
  REM Zo=((120*3.145)/(Ereff** -.5))/(X+1.393+.667LOG(X+1.444))
  LPRINT
  LPRINT TAB(5); W; TAB(30); E1; TAB(50); Z
NEXT W
END
D=(1-X)^2
E1=A+B*C+.04*B*D
REM Ereff=((er+1)/2)+((Er-1)/2)*[(1+12/X)^(-.5)+.04(1-X)^2]
G=LOG((8/X)+X/4)
I=60/(E1^.5)
Z=G*I
REM Zo=[60LOG((8/X)+X/4)]/(Ereff^.5)
GOTO 140

```

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APPENDIX B

```

001 Program Microwave ( input,output );
002 {This program is used to design matching networks for }
003 {low-noise microwave amplifiers. }
004 Type sparameters = array[1..2,1..2] of real;
005 Magnitude = array[1..2,1..2] of real;
006 Direction = array[1..2,1..2] of real;
007 Realn = array[1..2,1..2] of real;
008 imagn = array[1..2,1..2] of real;
009
010 Var
011 A,Deltafactor,delta1,delta2,delta3,delta4,rad,PI: Real;
012 Kfactor,frequency,deltaangle,A1,B1,B2: Real;
013 Mags: Magnitude;
014 Angle: Direction;
015 Rl: Realn;
016 Im: imagn;
017 I,J: Integer;
018 name,verify: char;
019 GmaoMag,GmaoAng,GmDf,GADA,C1,D1,RLGD,ImGD,GS11Mag: Real;
020 GS11Ang,C2,D2,D3,C3,DenoMag,DenoAng,NumMag,NumAng: Real;
021 GmLMag,GmlAng,GmLconjugate: Real;
022 Zo,Zsn1,Zsn2,Zsn3,Zsn4,Zsn5,ZsnMag,ZsnAng,SMag,
023 SAng: Real;
024 YsnMag,YsnAng,YsnReal,YsnIm,Zo1,Zo2: Real;
025 ZLn1,ZLn2,ZLn3,ZLn4,ZLn5,SLMag,SLAng,ZLnMag: Real;
026 ZLnAng,YLnMag,YLnAng,YLnReal,YLnIm,ZLo1,ZLo2: Real;
027
028 Procedure Poltorect;
029 Var unit1,unit2,unit3,unit4,rad: real;
030 Inter1,Inter2: Real;
031 stable,Kay,locus: boolean;
032 Begin
033 rad:=(PI)/180;
034 Unit1:= delta1*cos(delta3*rad);
035 Unit2:= delta1*sin(delta3*rad);
036 Unit3:= delta2*cos(delta4*rad);
037 Unit4:= delta2*sin(delta4*rad);
038 Inter1:= (unit1-unit3);
039 Inter2:= (unit2-unit4);
040 Writeln('the sum of [S11*S22-S12*S22] = ',
041 Inter1:6:5,' + j ',Inter2:6:5);
042 deltafactor:= Sqrt(sqr(Inter1) + sqr(Inter2));
043 Locus:= Inter1 < 0;
044 If locus then
045 Deltaangle:= ((Arctan((Inter2/Inter1))*(1/rad)) + 180)
046 else
047 Deltaangle:= (Arctan((Inter2/Inter1))*(1/rad));
048 writeln('The deltafactor is ',deltafactor:6:5);
049 writeln('the deltaangle = ',deltaangle:5:2);
050 writeln('The next step is to calculate the Kfactor');
051 writeln;
052 Kfactor:= (1-Sqr(mags[1,1])-sqr(mags[2,2]) + sqr(deltafactor))/

```

```

053 (2*delta2);
054 writeln('The K factor of the device = ',Kfactor:5:4);
055 stable:= Kfactor > 1;
056 Kay:= deltafactor < 1;
057 If stable then begin
058     If kay then
059         writeln('The device is unconditionally stable');
060     end
061 else
062     writeln('The device is potentially unstable');
063 B1:=(1+Sqr(mags[1,1])-sqr(mags[2,2])-sqr(deltafactor));
064 B2:=(1+Sqr(mags[2,2])-sqr(mags[1,1])-sqr(deltafactor));
065 writeln('B1 = ',B1:4:3,' B2 = ',B2:4:3);
066 end; { Procedure Poltorect }
067
068 Procedure EchoOneLine;
069 var CurrentCharacter: Char;
070 begin
071     write('The Sparameters of the device ');
072     while not EOLN do begin
073         read(CurrentCharacter);
074         write(CurrentCharacter);
075     end;
076     writeln(' at ',frequency:4:2,' GHz. are');
077 end; { Procedure EchoOnline }
078 Function Realrect(mag,ang:real):real;
079 begin
080     Realrect:=(mag*cos(ang*rad));
081 end; { function Realrect }
082
083 Function Imrect(mag,ang:real):real;
084 begin
085     Imrect:=(mag*sin(ang*rad));
086 end; { function Imrect }
087
088 function size(A,B:real):Real;
089 begin
090     size:=sqrt(sqr(A) + sqr(B))
091 and; { function size }
092
093 function Shift(A,B:real):real;
094 Var Invert :Boolean;
095 begin
096     Invert:= A < 0;
097     If Invert then
098         Shift:=(Arctan(B/A)) * (1/Rad) + 180
099     else
100         Shift:=(Arctan(B/A)) * (1/Rad);
101 end; { function Shift }
102
103 Begin { Program Microwave }
104 PI:= 3.141592654;

```



```

105 Rad:=( 2*PI)/360;
106 writeln('Enter the Center Frequency in GHz. ');
107 Readln(frequency);
108 write('please enter the S parameters in polar form only');
109 writeln;
110 for I:= 1 to 2 do begin
111     for j:= 1 to 2 do begin
112         writeln;
113         writeln('Enter S',i:1,j:1,' magnitude only');
114         Readln(mags[i,j]);
115         writeln;
116         writeln('Enter S',i:1,j:1,' angle only');
117         readln(angle[i,j]);
118         RL[i,j]:=(Realrect(mags[i,j],angle[i,j]));
119         Im[i,j]:=(Imrect(mags[i,j],angle[i,j]));
120     end;
121 end;
122 writeln;
123 writeln('Is this input data correct ??? ');
124 writeln;
125 writeln('Enter the Magnitude of Gamma_o');
126 Readln(GmaoMag);
127 writeln('Enter the Phase of Gamma_o');
128 Readln(GmaoAng);
129 writeln('Enter the Characteristic Impedance of the Source');
130 Readln(Zo);
131 writeln('Enter the name of the device then "ENTER"');
132 EchoOnline;
133 for i:= 1 to 2 do begin
134     for j:= 1 to 2 do begin
135         writeln;
136         write('S',i:1,j:1,' = ',mags[i,j]:4:3);
137         write(' angle',i:1,j:1,' = ',angle[i,j]:4:3);
138         writeln(' degrees');
139         write('S',i:1,j:1,' in rectangular form is ');
140         writeln(RL[i,j]:5:5,' + j ',Im[i,j]:5:4);
141     end;
142 end;
143 delta1:=(mags[1,1]*mags[2,2]);
144 delta2:=(mags[1,2]*mags[2,1]);
145 delta3:=(angle[1,1]+angle[2,2]);
146 delta4:=(angle[1,2]+angle[2,1]);
147 writeln;
148 Poltorect;
149 GMDf:=(GmaoMag*Deltafactor); { finds magnitude of Gmmao*delta}
150 GADA:=(GmaoAng+DeltaAngle); { Phase of Gmmao*deltafactor}
151 write('The Deltafactor = ',Deltafactor:1:4,' /');
152 writeln(Deltaangle:3:2);
153 writeln('GMDf = ', GMDf:1:4);
154 writeln('GADA = ', GADA:1:4);
155 RLgd:=Realrect(GMDf,GADA); { Change to rectangular form }
156 IMGd:=Imrect(GMDf,GADA); { The Imaginary part }

```

```

157 writeln('The Real part of Gamma_o*Delta =',RLGD:1:4);
158 writeln('The Imaginary part = ',IMGD:1:4);
159 C1:=(RI[2,2] - RLGD); { Real part of S22 - Gammao*Delta}
160 writeln('The real part of S22 - Gamma_o*Delta =',C1:1:4);
161 D1:=(Im[2,2] - ImGD); { Imag part of S22 - Gammao*Delta}
162 writeln('The Imaginary part of Gamma-o*Delta =',D1:1:4);
163 GS11Mag:=(GmaoMag*Mags[1,1]); {Magnitude of Gmmao*S11}
164 GS11Ang:=(GmaoAng+Angle[1,1]); { Phase of Gamma_o * S11 }
165 C2:= Realrect(GS11Mag,GS11Ang); {Real part Gmma_o*S11}
166 D2:= Imrect(GS11Mag,GS11Ang); { Imaginary part }
167 writeln(' D2 = ***** ',D2:1:4);
168 C3:=(1-C2); { real part of 1 - Gamma_o * S11 }
169 D3:= - D2;
170 writeln('The real part 1-Gamma_o*S11=',C3:1:4);
171 Denomag:= Size(C3, D3); { Magnitude of C3 }
172 writeln('The Magnitude of C3 = **', Denomag:1:4);
173 DenoAng:= Shift(C3,D3); { Phase of C3 }
174 writeln('The Phase of C3 = ', DenoAng:1:4);
175 Nummag:= Size(C1,D1); {Magnitude of S22 - Gamma_o*Delta }
176 writeln(' The Magnitude of the numerator =',Nummag:1:4);
177 NumAng:= Shift(C1,D1); { Phase of S22 - Gamma_o * Delta }
178 writeln('The Phase of the numerator =',NumAng:3:2);
179 GmLmag:=(NumMag/DenoMag);
180 GmLAng:=(NumAng - DenoAng);
181 GmLConjugate:= - GmLAng;
182 If GmLConjugate <= -180 Then
183     GmLConjugate:= GmLConjugate + 360;
184 writeln('GammaL = ',GmLmag:1:4,' / ',GmLconjugate:3:2);
185 writeln;
186 Zsn1:=Zo*(1-Sqr(GmaoMag)); { Real part of the numerator }
187 Zsn2:=2*Zo*Sin(GmaoAng*Rad);{ Imaginary part }
188 Writeln('The Numerator is ',Zsn1:1:4,' +j',Zsn2:1:4);
189 SMag:=Size(Zsn1,Zsn2); { Magnitude of the numerator }
190 SAng:=Shift(Zsn1,Zsn2);{ Phase of the numerator }
191 writeln('In Polar form Numerator =',SMag:1:4,' / ',SAng:3:2);
192 { writes the numerator in polar form }
193 Zsn3:= 1+Sqr(GmaoMag);
194 Zsn4:= 2*GmaoMag*Cos(GmaoAng*Rad);
195 Zsn5:= Zsn3 - Zsn4;
196 ZsnMag:= SMag/Zsn5; {Finds the magnitude of Zsn }
197 ZsnAng:= SAng;
198 write('The Source equivalent impedance for minimum-noise');
199 writeln(' figure is Zsn');
200 writeln(' Zsn = ',ZsnMag:1:4,' / ',ZsnAng:3:2);
201 writeln('The next step is to convert Zsn to Ysn');
202 YsnMag:=(1/ZsnMag);
203 YsnAng:=(-ZsnAng);
204 writeln('Ysn in polar form = ',YsnMag:1:4,' / ',YsnAng:3:2);
205 YsnReal:= Realrect(YsnMag,YsnAng);
206 YsnIm:= Imrect(YsnMag,YsnAng);
207 write('In rectangular form Ysn= ',YsnReal:1:4,' +j ');
208 writeln(YsnIm:1:4);

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```

209 { The next step is to utilise an open-circuited }
210 { A three-eighths wavelength stub which looks like }
211 { a shunt inductor of susceptance - j Yo.      }
212 Zo1:= ( 1/Abs(YsnIm));
213 writeln('Zo1 = ',Zo1:3:3, ' Ohms');
214 { The next step is to use a quarter-wave Transformer }
215 { to transform the load resistance of 50 Ohms to the }
216 { load equivalent conductance of Ysn (Real).      }
217 Zo2:= Sqrt(Zo/Abs(YsnReal));
218 writeln('Zo2 = ',Zo2:3:3, ' Ohms');
219 ZLn1:=Zo*(1-Sqr(GmLMag)); {Real part of numerator}
220 ZLn2:=2*Zo*Sin(GmLAng*Rad);{ Imaginary part }
221 Writeln('The Numerator is ',ZLn1:1:4,'+j',ZLn2:1:4);
222 SLMag:=Size(ZLn1,ZLn2); { Magnitude of the numerator }
223 SLAng:=Shift(ZLn1,ZLn2);{ Phase of the numerator }
224 writeln('In Polar form Numerator =',SLMag:1:4,'/',SLAng:3:2);
225 { Writes the numerator in polar form }
226 ZLn3:= 1 + Sqr(GmLMag);
227 ZLn4:= 2*GmLMag*Cos(GmLAng*Rad);
228 ZLn5:= ZLn3 - ZLn4;
229 ZLnMag:= SLMag/ZLn5; {Finds the magnitude of Zsn }
230 ZLnAng:= SLAng;
231 write('The load equivalent impedance for minimum-noise');
232 writeln(' figure is ZLn');
233 writeln(' ZLn = ',ZLnMag:1:4,'/',ZLnAng:3:2);
234 writeln('The next step is to convert ZLn to YLn');
235 YLnMag:=(1/ZLnMag);
236 YLnAng:=(-ZLnAng);
237 writeln('YLn in polar form = ',YLnMag:1:4,'/',YLnAng:3:2);
238 YLnReal:= Realrect(YLnMag,YLnAng);
239 YLnIm:= Imrect(YLnMag,YLnAng);
240 write('In rectangular form YLn= ',YLnReal:1:4,'+j ');
241 writeln(YLnIm:1:4);
242 { The next step is to utilise an open-circuited }
243 { Three-eighths wavelength stub which looks like }
244 { a shunt inductor of susceptance - j Yo.      }
245 ZLo1:= ( 1/Abs(YLnIm));
246 writeln('ZLo1 = ',ZLo1:3:3, ' Ohms');
247 { The next step is to use a quarter-wave Transformer }
248 { to transform the load resistance of 50 Ohms to the }
249 { load equivalent conductance of YLn (Real).      }
250 ZLo2:= Sqrt(Zo/Abs(YLnReal));
251 writeln('ZLo2 = ',ZLo2:3:3, ' Ohms');
252 end. { end of program microwave }

```